

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 23, 2024

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

LG653448698

LABORATORY GROWN DIAMOND

EMERALD CUT

9.54 X 6.99 X 4.82 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.09 CARATS

F

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

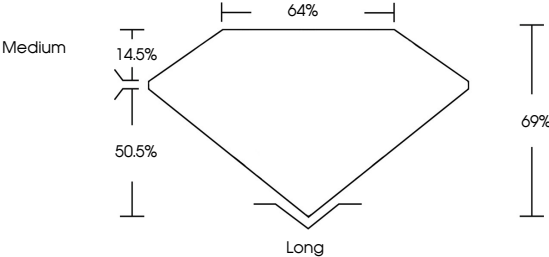
NONE

Inscription(s)

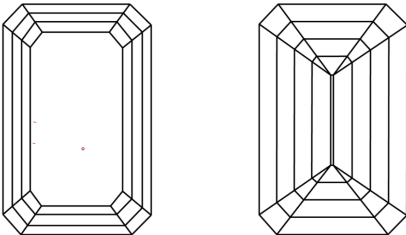
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG653448698

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR



D E F G H I J

Faint Very Light Light

CLARITY

IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³


Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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
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EMERALD CUT

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Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

3.09 CARATS

F

VS 1

69%

64%


Medium

Long

EXCELLENT

EXCELLENT

NONE

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Cutlet

Polish

Symmetry

Fluorescence

Inscription(s)

None

EXCELLENT

EXCELLENT

NONE

None

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